

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: S.V. Sreenivasan et al.	Art Unit	: 1732
Serial No.	: 10/788,700	Examiner	: Matthew J. Daniels
Filed	: February 27, 2004	Conf. No.	: 6995
Title	: FULL-WAFER OR LARGE AREA IMPRINTING WITH MULTIPLE SEPARATED SUB-FIELDS FOR HIGH THROUGHPUT LITHOGRAPHY		

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Commissioner for Patents
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AMENDMENT UNDER 37 C.F.R. §1.116

In response to the Office Action having a mailing date of September 19, 2007 (the "Final Office Action"), with a three-month shortened statutory period set to expire on December 19, 2007, please amend the above identified application as follows: